

5-1-02
PATENTS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Charles T. Black, et al..

Examiner: Unassigned

Serial No.: Unassigned

Art Unit: Unassigned

Filed: Herewith

Docket: BUR919990064US2 (12486A)

For: FERAM CELL WITH INTERNAL
OXYGEN SOURCE AND METHOD
OF OXYGEN RELEASE

Dated: August 10, 2001

Assistant Commissioner for Patents
United States Patent and Trademark Office
Washington, D.C. 20231

10857 U.S. PTO
09/927694
08/10/01

INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R. §§1.56, 1.97 and 1.98, it is respectfully requested that the following references, which are also listed on the attached form PTO-1449, be made of record in the above-identified patent application.

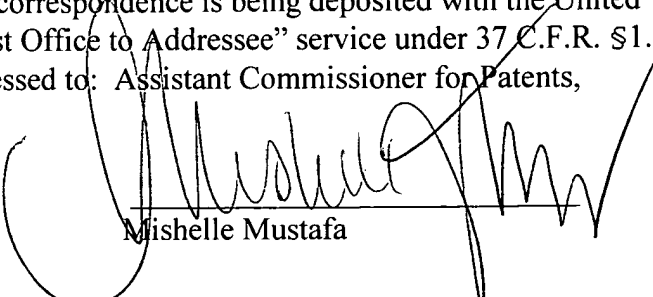
1. U.S. Patent No. 5,624,864, issued April 29, 1997 to Arita, et al.;
2. U.S. Patent No. 5,658, 820, issued August 19, 1997 to Chung;

CERTIFICATE OF MAILING BY "EXPRESS MAIL"

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I hereby certify that this correspondence is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 C.F.R. §1.10 on the date indicated above and is addressed to: Assistant Commissioner for Patents, Washington, DC 20231.

Dated: August 10, 2001


Michelle Mustafa

3. U.S. Patent No. 5,702,970, issued December 30, 1997 to Choi;
4. U.S. Patent No. 5,716,875, issued February 10, 1998 to Jones, Jr., et al.;
5. U.S. Patent No. 5,736,422, issued April 7, 1998 to Lee, et al.;
6. U.S. Patent No. 5,784,310, issued July 21, 1998 to Cuchiario, et al.;
7. U.S. Patent No. 5,812,442, issued September 22, 1998 to Yoo;
8. U.S. Patent No. 5,821,005, issued October 13, 1998 to Kijima, et al.;
9. U.S. Patent No. 5,822,239, issued October 13, 1998 to Ishihara, et al.;
10. European Patent No. 883 167 A2, issued December 9, 1998;
11. J.R. McBride, et al., "Growth and Characterization of Relatively Sputtered Thin-Film Platinum Oxides," J. Appl. Phys., Vol. 69, No. 3, pp. 1596-1604 (1991);
12. J.-H.. Joo, et al., "Improvement of Leakage Currents of Pt/(Ba, Sr) TiO/Pt Capacitors," Appl. Phys. Lett., Vol. 70, No. 22, pp. 3053-3055 (1997);
13. Y. Abe, et al., "Preparation of Oxygen-Containing Pt and Pt Oxide Thin Films by Reactive Sputtering and Their Characterization," Jpn. J. Appl. Phys., Vol. 37, No. 8, pp. 4482-4480 (1998); and
14. Y. Tsunemine, et al., "A Manufacturable Integration Technology of Sputter-BST Capacitor With a Newly Proposed Thick Pt Electrode," Paper 30-3, IEDM (December 1998).

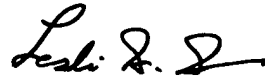
Pursuant to 37 C.F.R. §1.98(d), copies of the references listed on the enclosed Form PTO-1449 are not provided since they were previously made of record in parent application Serial No. 09/325,857 filed June 4, 1999. The references were cited in the Information Disclosure Statement filed concurrently with the application on June 4, 1999.

Consideration of this Information Disclosure Statement is respectfully requested, since the information provided herewith may be material to the examination of the

present application as defined under 37 C.F.R. §1.56. This statement is not intended to represent that a search has been performed or that no other art than that identified herein exists.

The instant Information Disclosure Statement is being submitted concurrent with the filing of the present application. Therefore, this filing is made under 37 C.F.R. §1.97(b)(1). An Information Disclosure Statement filed under 37 C.F.R. §1.97(b)(1) requires neither certification nor fee.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Leslie S. Szivos".

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